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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of : **Confirmation No. 7747**  
Mamoru NAKASUJI et al. : Docket No. 2003-1217A  
Serial No. 10/651,105 : Group Art Unit 2881  
Filed August 29, 2003 : Examiner James P. Leybourne  
ELECTRON BEAM SYSTEM :

**RESPONSE TO RESTRICTION REQUIREMENT**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

THE COMMISSIONER IS AUTHORIZED  
TO CHARGE ANY DEFICIENCY IN THE  
FEES FOR THIS PAPER TO DEPOSIT  
ACCOUNT NO. 23-0975

Sir:

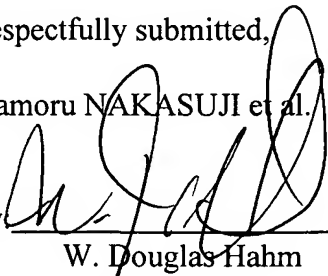
In response to the Restriction Requirement of November 2, 2004, Applicants hereby elect the invention of Group I, claims 1-26 and 54-62, drawn to a projection type transmission microscope, without traverse, for further prosecution.

In view of this election, a full examination on the merits of the present application is respectfully requested.

Respectfully submitted,

Mamoru NAKASUJI et al.

By

  
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